

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of)
)
 Yamazaki et al.)
)
 Serial No.: 09/724,002)
)
 Filed: November 28, 2000)
)
 For: Film Deposition Apparatus And)
 Method Of Manufacturing A Light)
 Emitting Device Using The)
 Apparatus)
)
 Art Unit: 1763)
)
 Confirmation No.: 7243)
)
 Examiner: K. Moore)

Commissioner for Patents
P.O. Box 1450
Alexandra, VA 22313-1450

AMENDMENT I

Sir:

Applicants have the following response to the Office Action of January 24, 2007.

Please amend in the above-identified application as follows: